

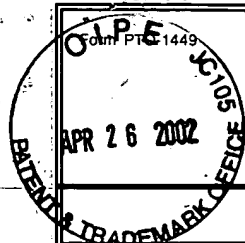
#19

200 Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Welman Li et al.			
				FILING DATE September 1, 1999		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ER	AA	5,801,399	9/98	Hattori et al.			
↑	AB	5,994,730	11/99	Shrivastava et al.			
	AC	6,040,619	3/00	Wang et al.			
	AD	6,060,765	5/00	Maeda			
	AE	6,060,766	3/00	Mehta et al.			
↓	AF	6,133,613	10/00	Yao et al.			
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						

EXAMINER <i>Eric Kuhl</i>	DATE CONSIDERED <i>12/19/01</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1208		SERIAL NO. 09/388,826	
LIST OF ARTS BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin (Michael) Li			
				FILING DATE 09/01/99		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ER	AA	6,268,282 B1	07/31/01	Sandhu et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes: No
	AL						
	AM						
	AN						
	AO						
	AP						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER				DATE CONSIDERED			
E. K. Han				5/20/02			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

#24

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICEATTY. DOKK
MI22-1208SERIAL NO.
09/388,826LIST OF ART CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Weimin (Michael) Li et al.FILING DATE
September 1, 1999GROUP
2813

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ER	AA	6,087,267	07/11/2000	Dockrey et al.			
ER	AB	5,543,654	08/06/1996	Dennen			
ER	AC	5,656,330	08/12/1997	Niiyama et al.			
ER	AD	5,872,035	02/16/1999	Kim et al.			
ER	AE	4,444,617	04/24/1984	Whitcomb			
ER	AF	6,071,799	06/06/2000	Park et al.			
ER	AG	5,691,212	11/25/1997	Tsai et al.			
ER	AH	US 6,187,657 B1	02/13/2001	Xiang et al.			
ER	AI	5,792,689	08/11/1998	Yang et al.			
ER	AK	09/773,462		Rolfson et al.			01/31/2001

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		
	AS		
	AT		

EXAMINER

Eusfile

DATE CONSIDERED

5/20/02

 RECEIVED
 APR 30 2002
 TECHNOLOGY CENTER 2800

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

